

# Method of selecting layer thicknesses of a reflective element for extreme ultra violet radiation

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Inventor: BRAUN STEFAN (DE); MAI HERMANN (DE)

Applicant: FRAUNHOFER GES FORSCHUNG (DE)

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G21K1/06; G02B5/08

- European: G02B5/08V; G02B5/08R; G21K1/06B; Y01N4/00






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Cited documents:

 US6295164  
 EP1065568  
 US5307395  
 US5086443  
 XP008007468  
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## Abstract of EP1351258

Thicknesses of molybdenum and silicon layers are selected to locate nodes of the standing electromagnetic wave field at interfaces. Alternatively they are selected to locate the antinodes before or after interfaces.

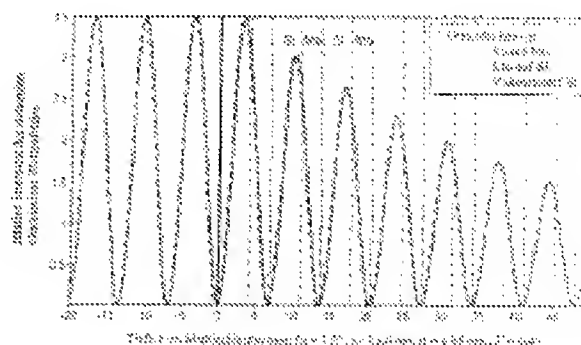


Figure 1

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